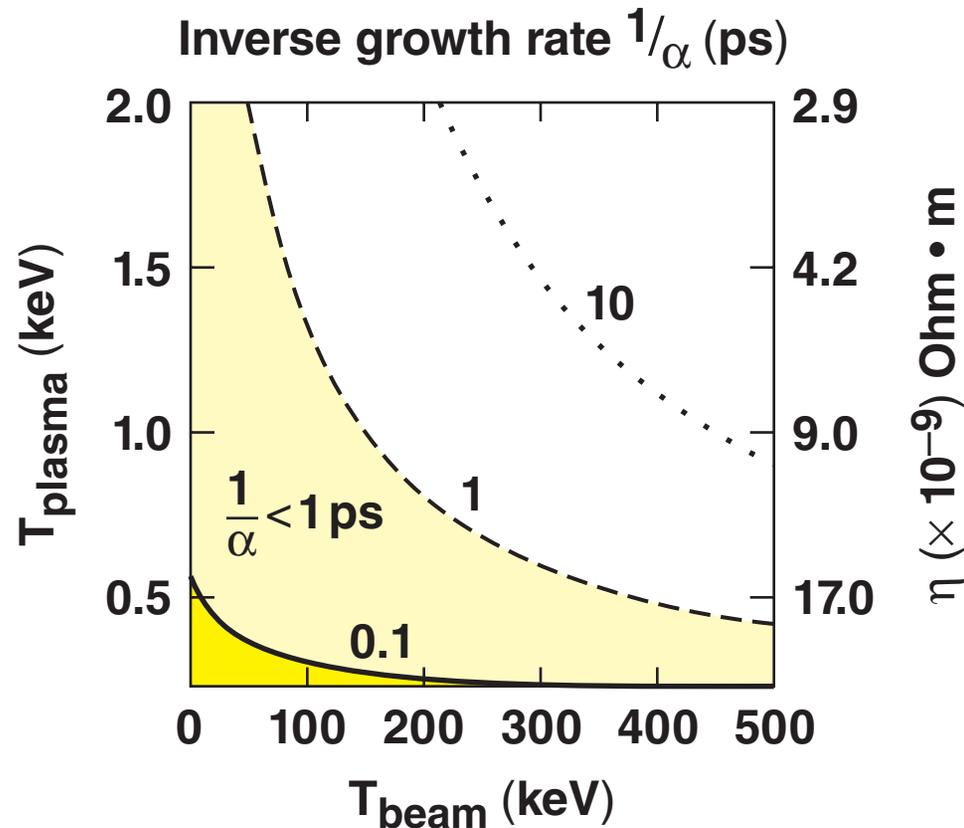


# Numerical Studies of MeV Electron Transport in Fast-Ignition Targets



J. Myatt, A. V. Maximov, R. W. Short,  
J. A. Delettrez, and C. Stoeckl  
University of Rochester  
Laboratory for Laser Energetics

46th Annual Meeting of the  
American Physical Society  
Division of Plasma Physics  
Savannah, GA  
15–19 November 2004

## Summary

**We have determined the maximum allowable transport distance to be no more than several tens of microns**

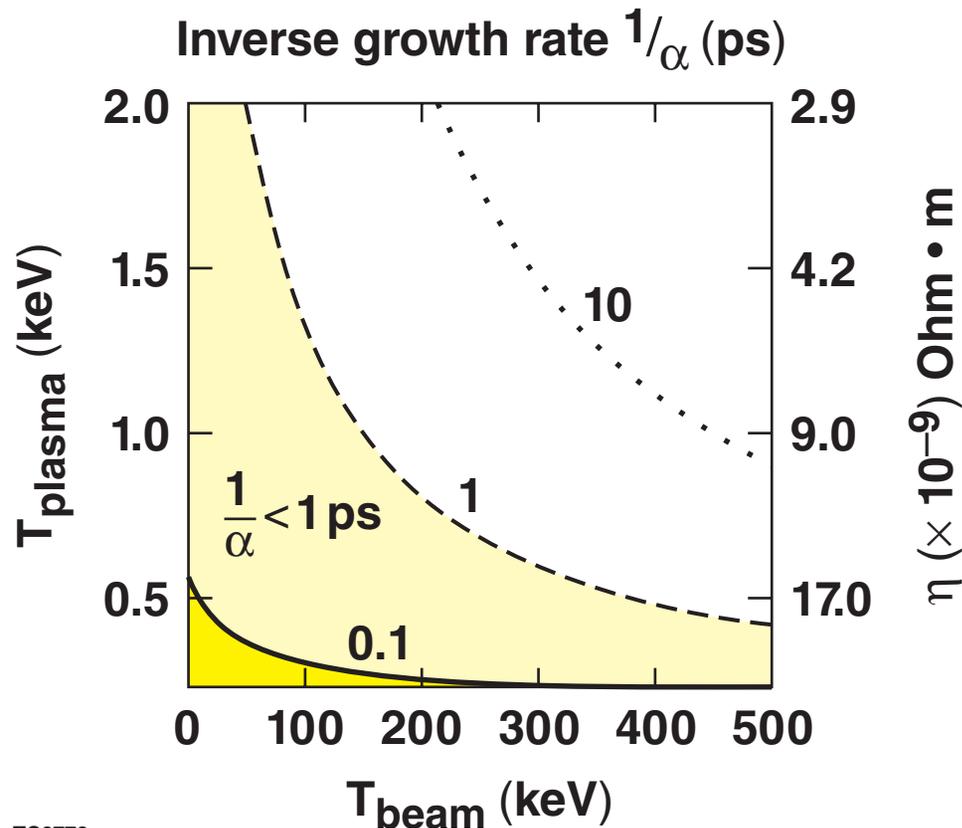
---



- **Transport efficiency in the FI scheme has been investigated numerically using the hybrid-implicit PIC code Lsp.<sup>1</sup>**
  - **Unlike Monte Carlo, the effects of self-fields are included.**
- **Three-dimensional calculations of 1-MeV electron beams have been made with parameters relevant to OMEGA EP imploded cryogenic DT targets.**
- **Resistive filamentation of beam current plays a role for these parameters.**
  - **Finite collisionality between the cold-electron return current and plasma ions leads to filamentation of the beam current and emittance growth.**
  - **Subpicosecond growth times even for 1-keV DT plasma.**
  - **Growth rate depends upon beam thermal spread (temperature).**

# Subpicosecond growth times for resistive filamentation can be obtained, even for hydrogenic ( $Z = 1$ ) plasma at 1 keV

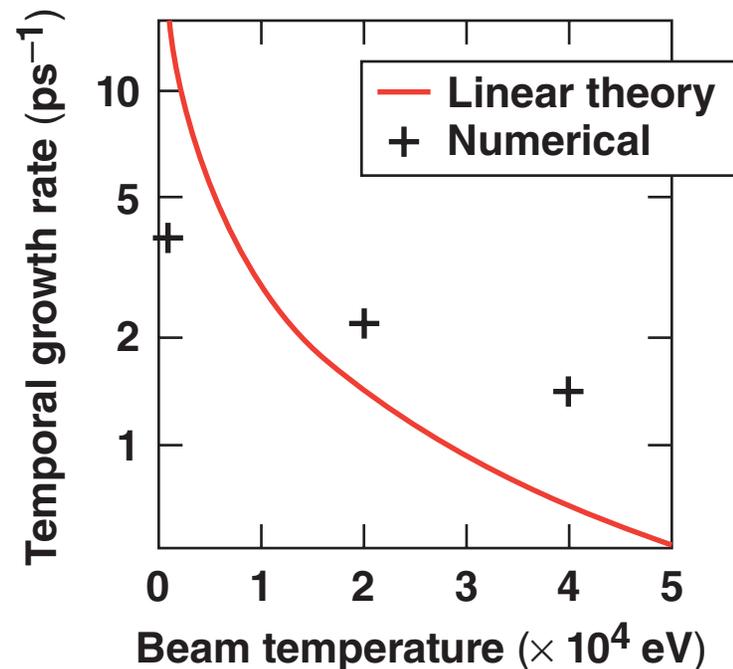
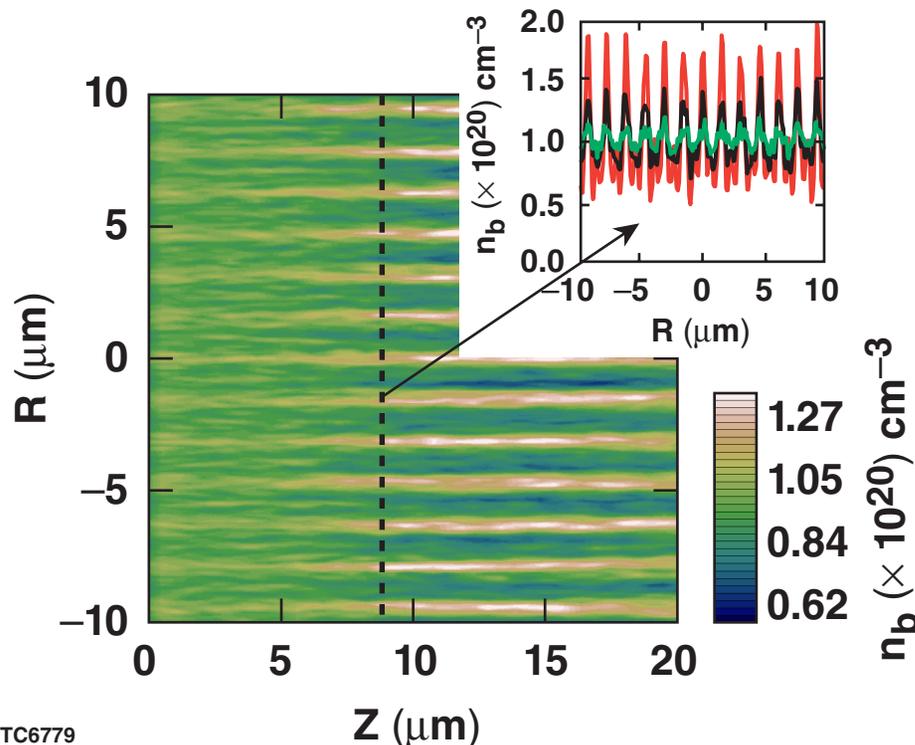
- In the transport region, the collisionless current filamentation instability gives way to resistive filamentation.



- Collisionless Weibel suppressed for small  $n_b/n_p$
- Silva *et al.*, (PoP 2004) conclude  $n_b/n_p < 0.1$  sufficient for 10-keV beam
- Resistive filamentation:  $\alpha(\eta, \beta_b, T_b, K, \omega_b)$
- Validity of Ohm's Law

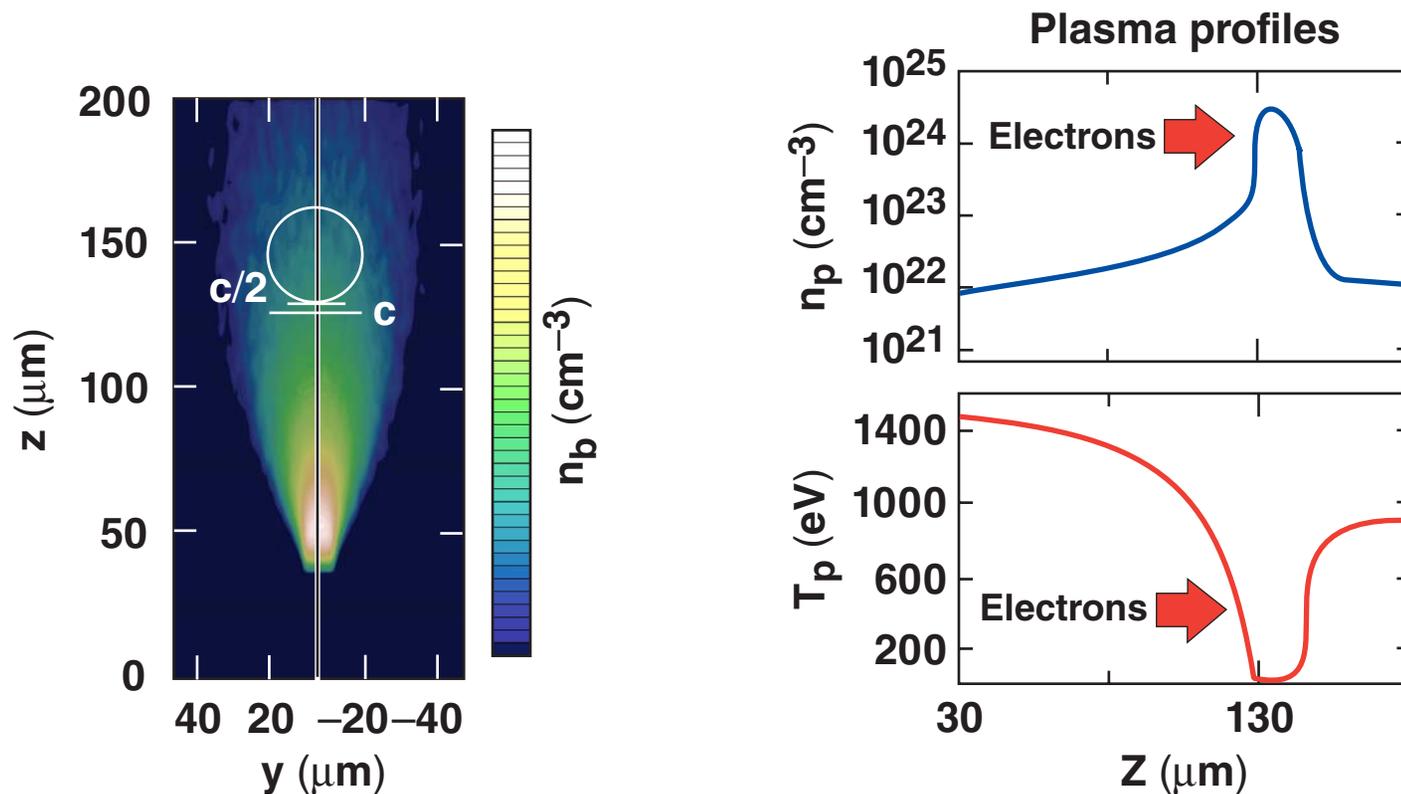
# Hybrid-implicit PIC (Lsp) is well suited to modeling of the transport region and is able to correctly describe resistive filamentation

- We have benchmarked the code against the linear theory.
- Scattering of cold return current with ions (finite resistivity) leads to resistive filamentation; electron inertial helps for  $\alpha \gtrsim v_{ei}$ .

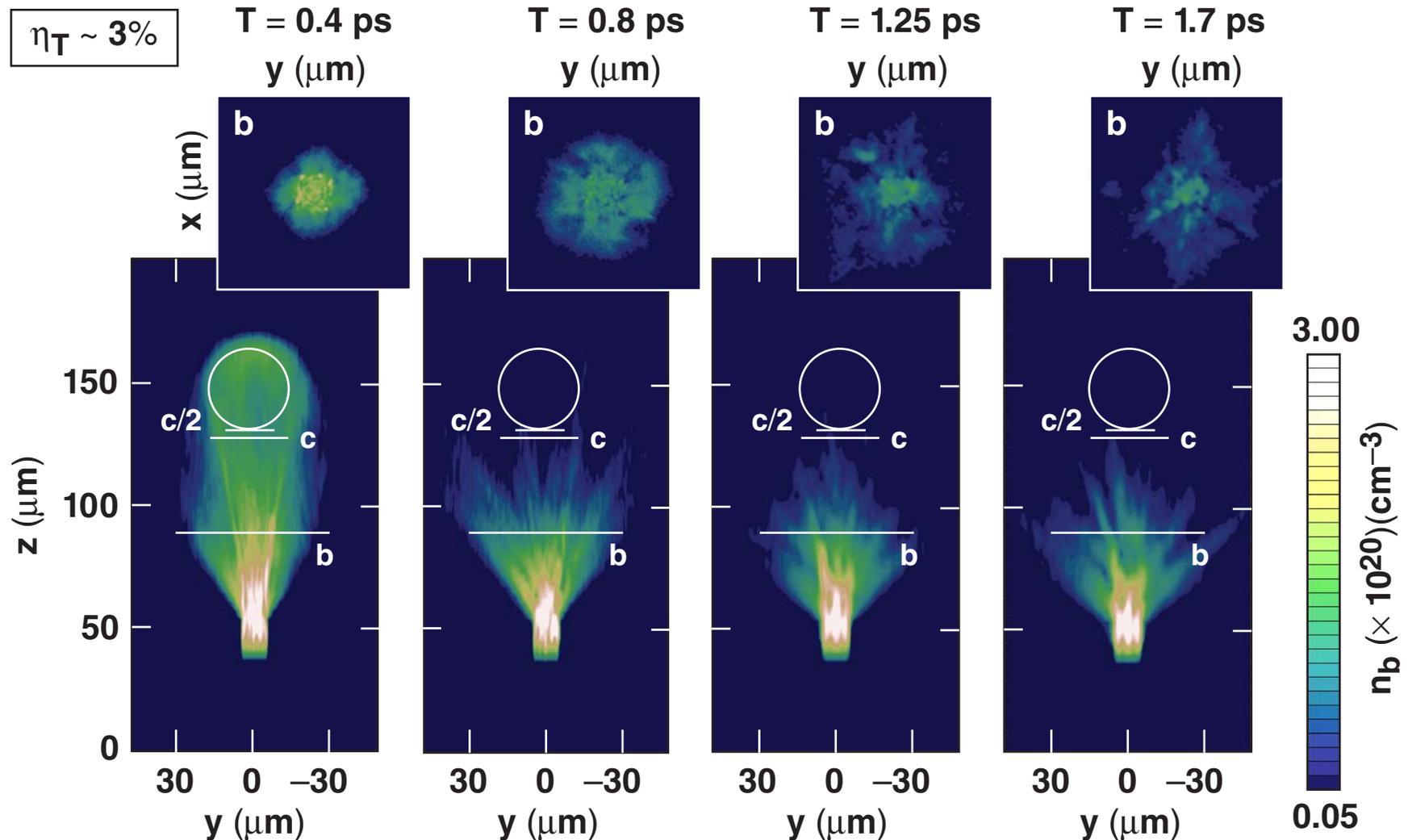


# We have evaluated transport efficiency for OMEGA EP parameters as a function of beam temperature and stand-off distance for the core

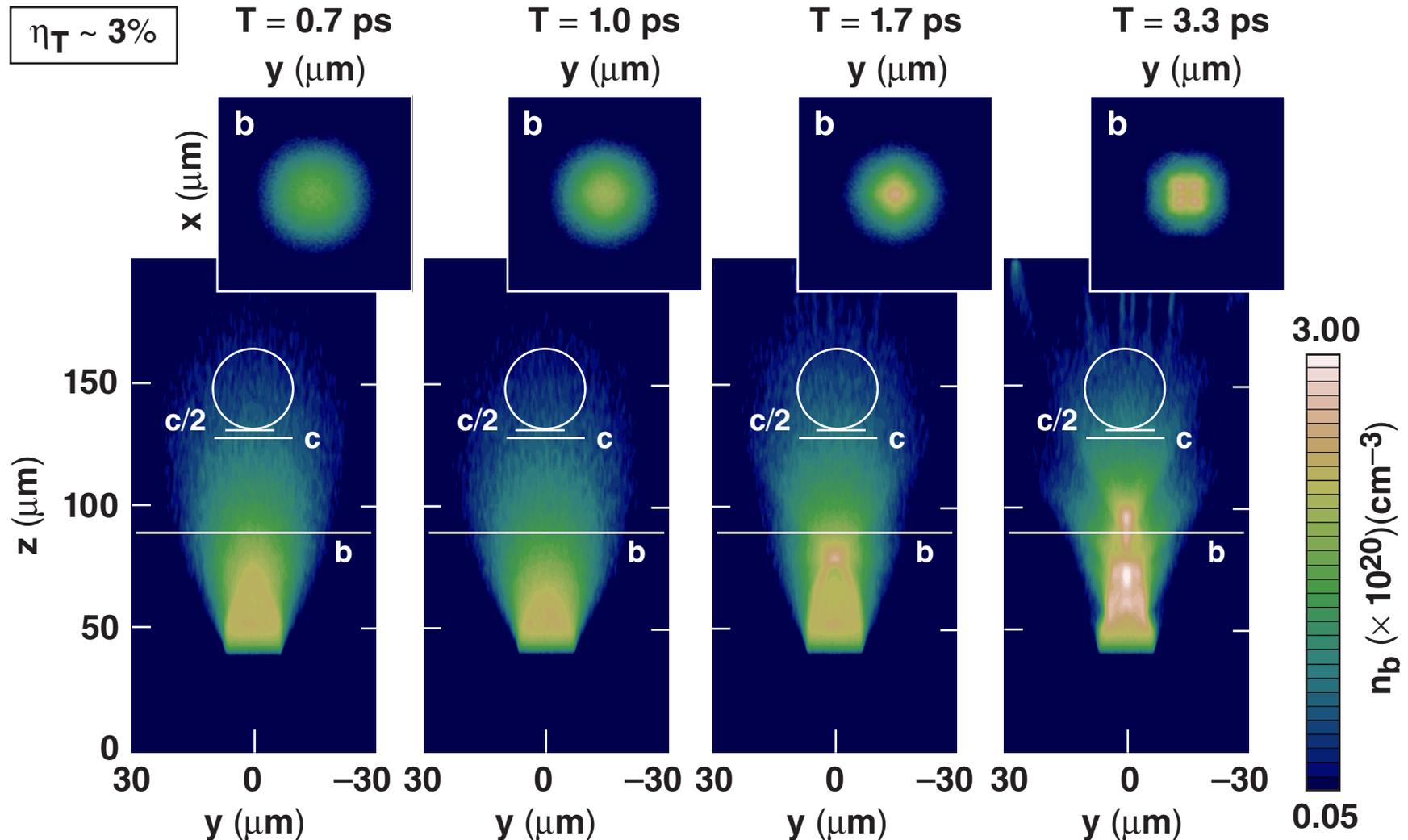
- OMEGA EP relevant parameters are chosen for the beam source:  $n_b \sim 10^{20}$ ,  $I_b \sim 2$  MA,  $r_G \sim 10$   $\mu\text{m}$
- Transport efficiency is calculated by measuring the fractional energy flux of hot electrons through the compressed shell/core.



# An initially well-collimated beam has a poor transport efficiency due to the rapid onset of beam spraying

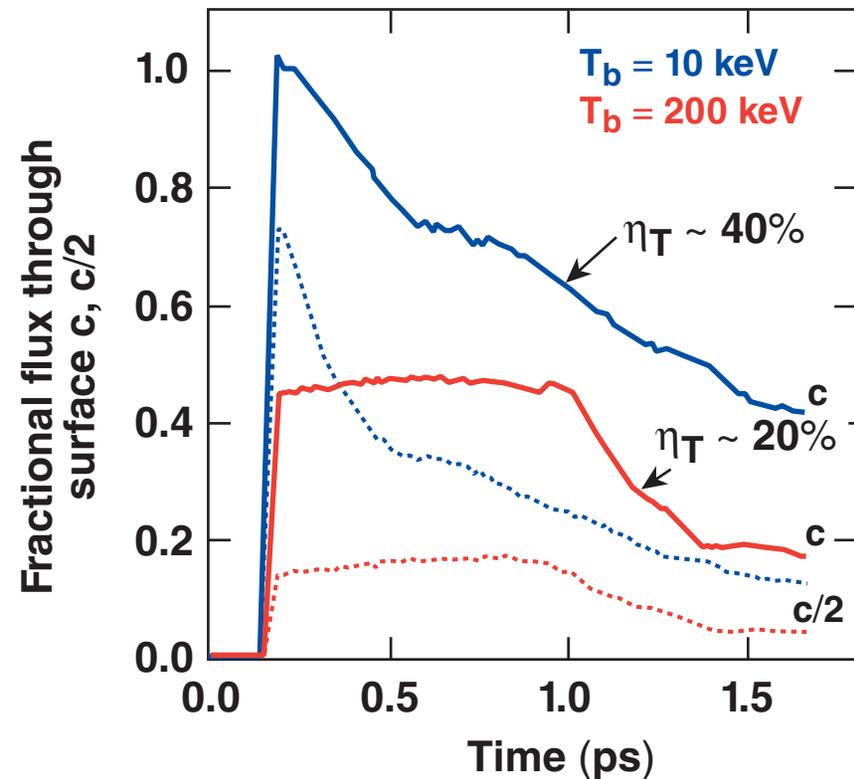
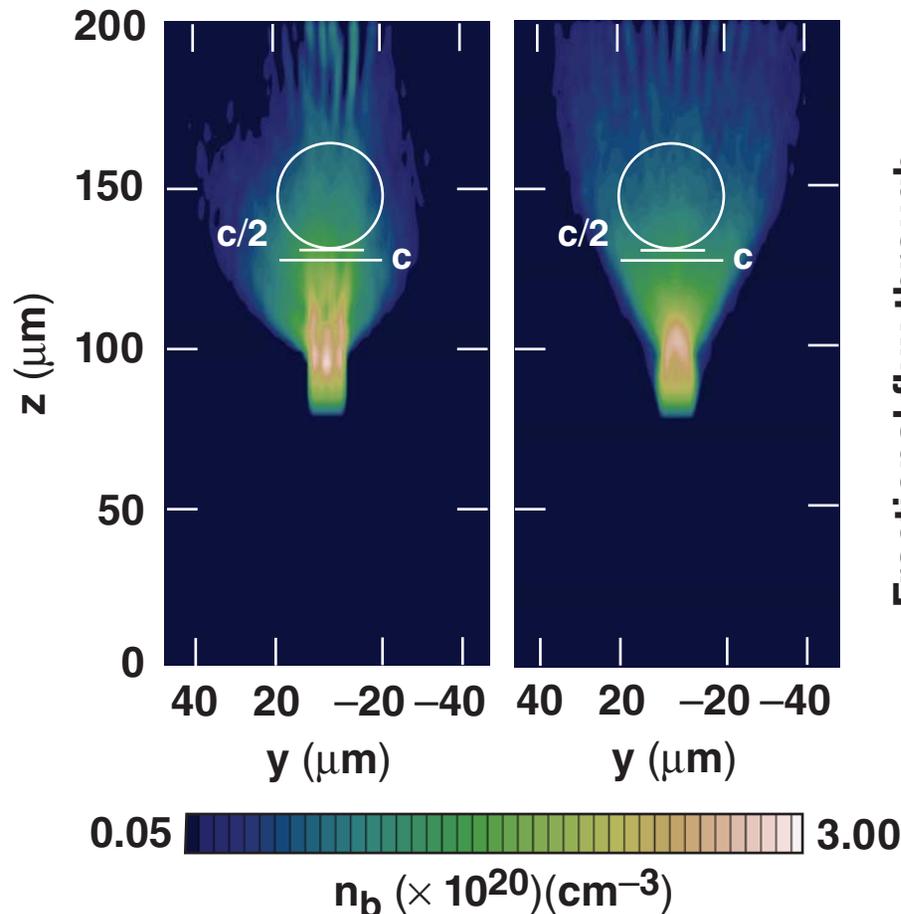


# Beam temperatures greater than 100 keV suppress filamentation, but have a significant initial divergence



# Reasonable efficiencies can be obtained for stand-off distances of $\lesssim 40 \mu\text{m}$ and moderate beam temperatures

- The cold beam sees an order of magnitude improvement in efficiency.
- Geometric losses are smaller.
- The beam is weaker [ $(n_b/n_p)$  smaller].



## Summary/Conclusions

**We have determined the maximum allowable transport distance to be no more than several tens of microns**



- **Transport efficiency in the FI scheme has been investigated numerically using the hybrid-implicit PIC code Lsp.<sup>1</sup>**
  - **Unlike Monte Carlo, the effects of self-fields are included.**
- **Three-dimensional calculations of 1-MeV electron beams have been made with parameters relevant to OMEGA EP imploded cryogenic DT targets.**
- **Resistive filamentation of beam current plays a role for these parameters.**
  - **Finite collisionality between the cold-electron return current and plasma ions leads to filamentation of the beam current and emittance growth.**
  - **Subpicosecond growth times even for 1-keV DT plasma.**
  - **Growth rate depends upon beam thermal spread (temperature).**

# We have evaluated transport efficiency for OMEGA EP designs as a function of beam temperature and stand-off distance from core

- An electron beam is generated by promotion from the background over a 20- $\mu\text{m}$  spot with a pulse duration of 10 ps.
- FI relevant parameters are chosen the beam source.

$$n_b \sim 10^{20} \text{ cm}^{-3}, I_b \sim 2 \text{ MA}, r_G = 10 \mu\text{m}$$

